

Application Serial No. 10/051,494 Docket No.: SC11692ZP/MTRL005US0

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Passlack et al. )
Serial No.: 10/051,494 )
Filed: January 18, 2002 )

In re Application of:

For: ARTICLE COMPRISING AN OXIDE LAYER ON A GAAS-BASED SEMICONDUCTOR STRUCTURE AND METHOD OF FORMING SAME

Examiner: G. Fourson III

Group Art Unit: 2823

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## CERTIFICATION OF MAILING UNDER 37 C.F.R. 1.8

)

I hereby certify that I have cause the documents indicated herein to be deposited with the United States Postal Service to Addressee under 37 CFR 1.8 on the date indicated below and address to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Date: January-23,-2004

Signature:

Printed Name:

Mary Schnaiter

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## REQUEST FOR EXTENSION OF TIME

Dear Sir:

In response to the Office action dated September 23, 2003, Applicant hereby request a one (1) month Extension of Time to File a Response.

Our check to cover the fee of \$110.00 is enclosed. If this check is omitted, or if there are additional fees associated with the filing of this Request for Extension of Time, the Commissioner is hereby authorized to charge or credit any overpayment to the deposit account of Hulsey, Grether, Fortkort & Webster, LLP, Deposit Account No. 50-2726.

Respectfully submitted,

HULSEY, GRETHER, FORTKORT & WEBSTER, LLP

By:

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Dated: January 23, 2004